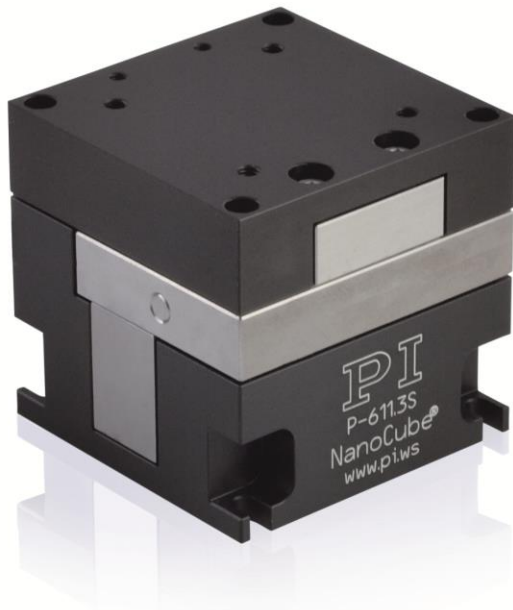


NanoCube® XYZ Piezo System

Compact Multi-Axis Piezo System for Nanopositioning and Fiber Alignment



P-611.3

- Travel range to 120 μm \times 120 μm \times 120 μm
- Ultracompact: 44 mm \times 44 mm \times 44 mm
- Resolution to 0.2 nm
- Fast response behavior
- Zero-play, high-precision flexure guide system
- Outstanding lifetime due to PICMA® piezo actuators
- For fast scanning
- Version with integrated fiber holder
- Particularly inexpensive systems

Outstanding lifetime thanks to PICMA® piezo actuators

The patented PICMA® piezo actuators are all-ceramic insulated. This protects them against humidity and failure resulting from an increase in leakage current. PICMA® actuators offer an up to ten times longer lifetime than conventional polymer-insulated actuators. 100 billion cycles without a single failure are proven.

High guiding accuracy due to zero-play flexure guides

Flexure guides are free of maintenance, friction, and wear, and do not require lubrication. Their stiffness allows high load capacity and they are insensitive to shock and vibration. They are 100 % vacuum compatible and work in a wide temperature range.

Specifications

| | P-611.3S P-611.3SF | P-611.3O P-611.3OF | Unit | Tolerance |
|---|---|---|------|--------------|
| Active axes | X, Y, Z | X, Y, Z | | |
| Motion and positioning | | | | |
| Integrated sensor | SGS | | | |
| Travel range at -20 to 120 V, open loop | 120 / axis | 120 / axis | μm | +20 % / -0 % |
| Travel range, closed loop | 100 / axis | – | μm | |
| Resolution, open loop | 0.2 | 0.2 | nm | typ. |
| Resolution, closed loop | 1 | – | nm | typ. |
| Linearity error | 0.1 | – | % | typ. |
| Repeatability | <10 | – | nm | typ. |
| Pitch in X, Y | ±5 | ±5 | μrad | typ. |
| Tilt θ_x (motion in Z) | ±10 | ±10 | μrad | typ. |
| Yaw in X | ±20 | ±20 | μrad | typ. |
| Yaw in Y | ±10 | ±10 | μrad | typ. |
| Tilt θ_y (motion in Z) | ±10 | ±10 | μrad | typ. |
| Mechanical properties | | | | |
| Stiffness | 0.3 | 0.3 | N/μm | ±20 % |
| Resonant frequency X / Y / Z, no load | 350 / 220 / 250 | 350 / 220 / 250 | Hz | ±20 % |
| Resonant frequency under load in X / Y / Z, 30 g | 270 / 185 / 230 | 270 / 185 / 230 | Hz | ±20 % |
| Resonant frequency under load in X / Y / Z, 100 g | 180 / 135 / 200 | 180 / 135 / 200 | Hz | ±20 % |
| Push/pull force capacity in motion direction | 15 / 10 | 15 / 10 | N | max. |
| Load capacity | 15 | 15 | N | max. |
| Drive properties | | | | |
| Ceramic type | PICMA® P-885 | PICMA® P-885 | | |
| Electrical capacitance | 1.5 | 1.5 | μF | ±20 % |
| Miscellaneous | | | | |
| Operating temperature range | -20 to 80 | -20 to 80 | °C | |
| Material | Aluminum, steel | Aluminum, steel | | |
| Dimensions | P-611.3S: 44 mm × 44 mm × 43.2 mm P-611.3SF: 48 mm × 50 mm × 44.2 mm | P-611.3O: 44 mm × 44 mm × 43.2 mm P-611.3OF: 44 mm × 50 mm × 44.2 mm | | |
| Mass | 0.32 | 0.32 | kg | ±5 % |
| Cable length | 1.5 | 1.5 | m | ±10 mm |
| Voltage connection | Sub-D 25 (m) | Sub-D 25 (m) | | |
| Sensor connection | Sub-D 25 (m) | – | | |
| Recommended electronics | E-503, E-505, E-663, E-664, E-727 | E-503, E-505, E-663, E-664, E-727 | | |

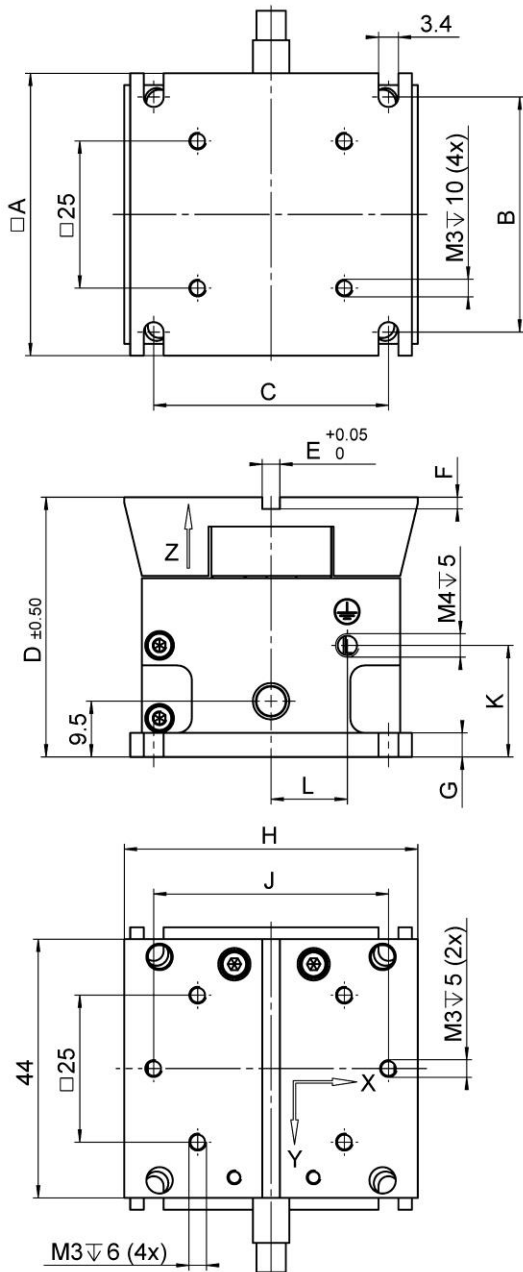
The resolution of the system is limited only by the noise of the amplifier and the measuring technology because PI piezo nanopositioning systems are free of friction.

Adapter cable with LEMO connectors for sensor and operating voltage available.

All specifications based on room temperature (22 °C ±3 °C).

Ask about customized versions.

Drawings / Images



| | A | B | C | D | E | F | G | H | J | K |
|-----------|----|------|------|------|---|---|-----|----|----|-----|
| P-611.3O | 44 | 38.2 | 37.8 | 43.2 | - | - | 3.5 | 44 | - | 3.5 |
| P-611.3S | 44 | 38.2 | 37.8 | 43.2 | - | - | 3.5 | 44 | - | 3.5 |
| P-611.3OF | 44 | 38.2 | 37.8 | 44.2 | 3 | 2 | 3.5 | 50 | 40 | 3.5 |
| P-611.3SF | 48 | 40 | 40 | 44.2 | 3 | 2 | 4.1 | 50 | 40 | 19 |

P-611.3, dimensions in mm

Ordering Information

P-611.3S

NanoCube® XYZ nanopositioning system, 100 µm × 100 µm × 100 µm, strain gauge sensors

P-611.3O

NanoCube® XYZ nanopositioning system, 120 µm × 120 µm × 120 µm, without sensor

P-611.3SF

NanoCube® XYZ nanopositioning system, 100 µm × 100 µm × 100 µm, strain gauge sensors, integrated fiber holder

P-611.3OF

NanoCube® XYZ nanopositioning system, 120 µm × 120 µm × 120 µm, without sensor, integrated fiber holder